

Application/Control No.	Applicant(s)/Patent under Reexamination	er -
10/756,855	OHTOMO ET AL.	
Examiner	Art Unit	
Luka D. Bataliffa	2662	

SEARCHED				
Class	Subclass	Date	Examiner	
356	5.01	5/10/2006	LDR	

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
	-			
East interfer	ence search	5/10/2006	LDR	

SEARCH NOT (INCLUDING SEARCH		)
	DATE	EXMR
356/3,3.01,3.06,4.01,5.01,5.1,5.11,7,8 ,9	5/10/2006	LDR
East text searches	5/10/2006	LDR
online search	5/10/2006	LDR
ECLA search	5/10/2006	LDR
IEEE search	5/10/2006	LDR